



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 22, 2026

IGI Report Number

LG793642326

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUSHION MODIFIED BRILLIANT

Measurements

8.88 X 6.72 X 4.51 MM

GRADING RESULTS

Carat Weight

2.10 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

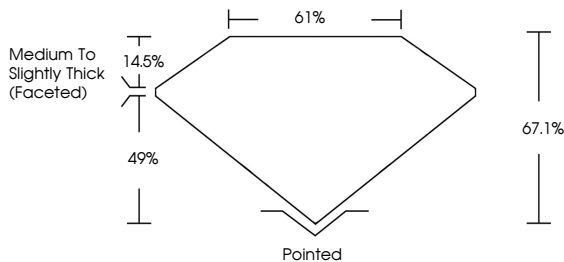
Inscription(s)

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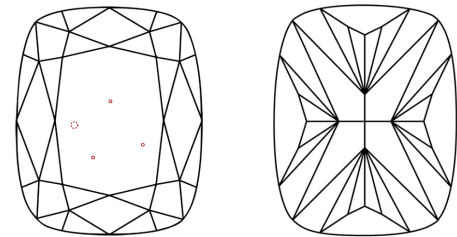
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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CUSHION MODIFIED BRILLIANT

8.88 X 6.72 X 4.51 MM

2.10 CARATS

E

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG793642326

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

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